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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuto TANAHASHI et al.**

Art Unit: **2815**

Application Number: **10/743,793**

Examiner: **Jay C. Kim**

Filed: **December 24, 2003**

Confirmation Number: **9788**

For: **Semiconductor substrate and manufacturing method thereof**

Attorney Docket Number: **032206**

Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

July 18, 2008

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated March 18, 2008 for 1 month from June 18, 2008 to July 18, 2008.

Attached please find a check in the amount of \$120.00 for the cost of the extension of time. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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